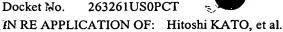
Docket No.

263261US0PCT



SERIAL NO: 10/518,025

FILED:

December 15, 2004

FOR:

CVD METHOD FOR FORMING SILICON NITRIDE FILM ON TARGET SUBSTRATE

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

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Transmitted herewith is an amendment in the above-identified application.

- ☐ No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- Additional documents filed herewith: Preliminary Amendment

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS		RATE		CALCULATIONS
TOTAL	15	MINUS	20	0	х	\$50	=	\$0.00
INDEPENDENT	. 2	MINUS	3	.0	х	\$200	= ,	\$0.00
		☐ MULTIPL	+	\$360	=	\$0.00		
		TOTAL OF ABOVE CALCULATIONS						\$0.00
		☐ Reduction by 50% for filing by Small Entity						\$0.00
		☐ Recordation of Assignment +					=	\$0.00
•						TOT	AL	\$0.00

Ш	Α	check	in	the	amount	of	<u>\$0.00</u>	is	attach	ied	l.
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- ☐ Credit card payment form is attached to cover the fees in the amount of \$0.00
- A Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- 🖾 If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

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